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ATTENTION: BOX AFTER FINAL  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1722

PATENT

Customer No. 22,852

Attorney Docket No. 04329.2230

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Kenji HASHIMOTO ) Group Art Unit: 1722  
Application No.: 09/503,170 ) Examiner: R. Davis  
Filed: February 14, 2000 )  
For: RESIN ENCAPSULATING )  
APPARATUS AND METHOD )  
USED IN A MANUFACTURE OF A )  
SEMICONDUCTOR DEVICE )

10C/faw  
4/30/03  
JL

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action of January 24, 2003, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

IN THE CLAIMS:

Please amend claims 1 and 8, as follows:

1. (Twice Amended) A resin encapsulating apparatus comprising:

a retaining section which retains a semiconductor device;

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